APR 2 6 2004

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known

Application Number 10/821,010

Filing Date 04/08/2004

First Named Inventor XIONG et al.

Group Art Unit Not Assigned Yet VIJAYAKUMAR

Examiner Name Name

Sheet 1 of 2 Attorney Docket Number 3723 – SP#215

			U.S	S. PATE	NT DO	CUMENTS		
Examiner Initials*	Cite No.1	Document Number		tion Date D-YYYY	Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant	
		Number- Kind Code 2 (if known)					Figures Appear	
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			FORE	IGN PA	TENT	DOCUMENTS		
Examiner Initials•	Cite No.1	Foreign Patent Docum	' "		ication ate	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages	
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Substitute for for				Application Number	10/821,010
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STATEMENT BY APPLICANT (use as many sheets as necessary)				First Named Inventor	XIONG et al.
				Group Art Unit	Not Assigned Yet 1793
· ·	•			Examiner Name	Not Assigned Yet
Sheet	2	of	2	Attorney Docket Number	3723 - SP#215

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials•	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Т
	3	HASEGAWA, K. et al., Proc. of 16 <sup>th</sup> ICEC/ICMC Proceedings, Amsterdam: Elsevier Science pp. 1413-1416. (1997)	
	4	DIMOS, D. et al., Orientation Dependence of Grain Boundary Critical Currents in YBa <sub>2</sub> Cu <sub>3</sub> O <sub>7-8</sub> Bicrystals, The American Physical Society, Physical Review Letters, Vol. 61, #2, pp. 219-222, (July 11, 1988)	
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		ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.M.V./	
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